



UNITED STATES PATENT and TRADEMARK OFFICE

UNDER SECRETARY OF COMMERCE FOR INTELLECTUAL PROPERTY AND  
DIRECTOR OF THE UNITED STATES PATENT AND TRADEMARK OFFICE  
WASHINGTON, D.C. 20231  
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PAPER NO. 6

In re Application of	:	
William M. Traut et al.	:	DECISION
Serial No. 10/073,184	:	ON
Filed: February 13, 2002	:	PETITION
For: VENT FOR AND METHOD OF	:	UNDER 708.02,V
CONCEALING AND VENTING A SEPTIC	:	
SYSTEM	:	

This is in response to the petition filed March 14, 2002, requesting that the above-identified application be granted Special Status under Sections 708.02 (V) of the MPEP and 37 CFR 1.102(c).

The petition has been considered and found to comply with the requirements set forth under the above-noted section. Accordingly the petition is **GRANTED**.

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